

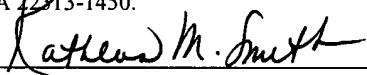
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shiva Prakash
Title: Atomic Force Microscopy Measurements Of Contact Resistance And Current-Dependent Stiction
Serial No. New – Divisional of Serial No. 10/202,439 filed 07/23/2002
Filing Date: Herewith
Prior Art Unit: 2856
Prior Examiner: R. Raevis
Atty Docket: 061450/0304608 (FID-101-D4)

MAIL STOP: Patent Applications
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Express Mail Label No. EV 342 415 418 US
Date of Deposit: July 3, 2003

I hereby certify that this correspondence and the documents referred to as attached hereto are being deposited with the United States Postal Service on the above date in an envelope marked as "Express Mail Post Office to Addressee," addressed to MAIL STOP Patent Applications, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Kathleen M. Smith

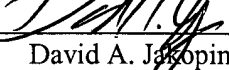
INFORMATION DISCLOSURE STATEMENT

Applicant submits herewith patents, publications or other information of which Applicant is aware which are believed to be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), nor as an admission that the information cited is, or is considered to be, material to patentability, nor an admission that no other material information exists. The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

The references cited herein were cited in the parent application Serial No. 10/202,439 filed July 23, 2002, and therefore copies are not included.

Respectfully submitted
PILLSBURY WINTHROP LLP

By 
David A. Jakopin Reg. No. 32,995

1600 Tysons Boulevard
McLean, VA 22102
Telephone No. 650-233-4500

[illegible]

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.